

GR 00 P 1583

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By: JP ~

Date: 8/4/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Klaus Lowack et al.  
Applic. No. : 09/817,963  
Filed : March 27, 2001  
Title : Method For The Metalization Of An Insulator  
And/Or A Dielectric  
Examiner : Brian K. Talbot  
Group Art Unit: 1762

A M E N D M E N T

Hon. Commissioner of Patents and Trademarks,  
Washington, D. C. 20231

S i r :

Responsive to the Office action dated April 4, 2003 kindly  
amend the above-identified application as follows:

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